

## TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

<b>Title of Invention</b>	[STRUCTURE APPLIED TO A PHOTOLITHOGRAPHIC PROCESS AND METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE]							
Application Number :								
Date :								
First Named Applicant:	Mr. SHUN-LI LIN							
Confirmation Number:								
Attorney Docket Number:	12398-US-PA							
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<table border="1"><tr><td>Submitted By:</td><td>Elec. Sign.</td><td>Sign. Capacity</td></tr><tr><td>Dr. BELINDA LEE Registered Number: 46,863</td><td>/Belinda Lee/</td><td>Agent</td></tr></table>			Submitted By:	Elec. Sign.	Sign. Capacity	Dr. BELINDA LEE Registered Number: 46,863	/Belinda Lee/	Agent
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Documents being submitted:	Files
us-fee-sheet	12398-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
us-assignment	12398-usassn.xml us-assignment.xsl us-assignment.dtd 12398assignment1.tif 12398assignment2.tif
us-request	12398-usrequ.xml us-request.dtd us-request.xsl
application-body	12398-trans.xml us-application-body.xsl application-body.dtd wipo.ent mathml2.dtd mathml2-qname-1.mod isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isogr3.ent isomfrk.ent isomopf.ent isomscr.ent isotech.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isolat1.ent isolat2.ent isonum.ent isopub.ent mmlextra.ent mmlalias.ent soextblx.dtd 12398us0001.tif 12398us0002.tif 12398us0003.tif
us-declaration	12398declaration1.tif
us-declaration	12398declaration2.tif
<b>Comments</b>  Please be kindly advised that the indicated fees of this EFS application is intended to be paid by credit card. However, in the event that the payment through credit card is unsuccessful, the Commissioner is authorized to charge the required fees in connection with this application to: Deposit Account No. 50-2620 (Order No. 12398-US-PA ), Deposit Account Name: Jianq Chyun Intellectual Property Office, Authorized User Name: Belinda Lee, E-mail: belinda@jcipgroup.com.tw; usa@jcipgroup.com.tw	